ATTY DKT. No.:

U.S. SERIAL NO .:

APPLICANT: TITLE:

AMAT/8245/DSM/BCVD/JW
UNKNOWN FILED: HEREWITH
APPLIED MATERIALS, INC.
METHOD OF DEPOSITING AN AMORPHOUS CARBON FILM FOR METAL ETCH

HARDMASK APPLICATION
INVENTOR: YUXIANG MAY WANG, ET AL.
EXPRESS MAIL NO.: EV335470192US

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